



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 31, 2024	
IGI Report Number	LG645401721
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.87 - 7.90 X 4.79 MM

GRADING RESULTS

Carat Weight	1.82 CARAT
Color Grade	E
Clarity Grade	SI 1
Cut Grade	IDEAL

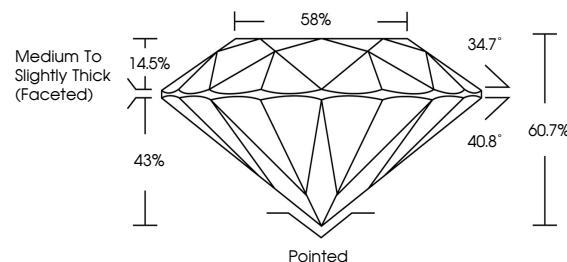
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG645401721

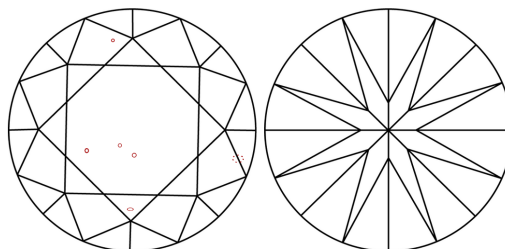
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG645401721
Report verification at lgi.org

PROPORTIONS

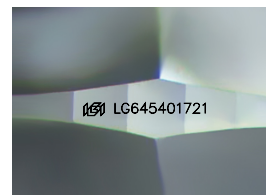


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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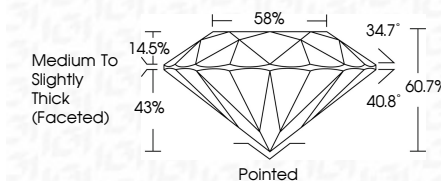
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GI Report No LG645401721
ROUND BRILLIANT

1.82 CARAT	1.82 CARAT
Color Grade	Color Grade
Clarity Grade	Clarity Grade
Cut Grade	Cut Grade
Depth	Depth
Table	Table
Girdle	Girdle
Culet	Culet
Polish	Polish
Symmetry	Symmetry
Fluorescence	Fluorescence
Medium to slightly Thick (faceted)	Medium to slightly Thick (faceted)
56%	56%
IDEAL	IDEAL
\$11	\$11

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(CVD) growth process.